



PATENT
0397-0404P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Hiroaki TAKEUCHI et al. Conf.: 4024

Appl. No.: 09/541,089 Group: 1762

Filed: March 31, 2000 Examiner: M. PADGETT

For: PLASMA PROCESSING METHOD

REPLY UNDER 37 C.F.R. § 1.111

Commissioner for Patents May 5, 2004
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In conjunction with the Request for Continued Examination being filed concurrently herewith, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes Amendments to the Claims; and Remarks.